IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Kelly M Stouffer

Confirmation No.: 5371

Art Unit: 1762

In re Application of:

Narwankar et al.

Application No.: 10/772,893

Filed: February 4, 2004

For: TAILORING NITROGEN PROFILE IN SILICON OXYNITRIDE USING RAPID THERMAL ANNEALING WITH AMMONIA UNDER ULTRA-LOW

PRESSURE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR §1.111

Dear Examiner:

This is in response to the Office Action mailed September 26, 2007. Applicants respectfully request the Examiner to enter this Amendment and consider the following remarks.

Amendments to the Specification begin on page 2 of this paper.

The Listing of Claims begins on page 4 of this paper.

Remarks/Arguments begin on page 14 of this paper.

I hereby certify that this correspondence is being deposited via EFS Web on the date below:

December 21, 2007

Date of Deposit

/Justin K. Brask/

Justin K. Brask, Reg. #61,080